Special Issue

Laser Micro- and Nano-Processing

Message from the Guest Editors

Numerous recent technological advances rely on controllable micro- and nano-fabrication techniques to improve the performance of devices in various applications (*e.g.*, in biomedicine, communications, and energy harvesting). Lasers are uniquely suited for a wide variety of fabrication applications at both the micro- and the nano- scales, in both the production and research environments. In light of this, we announce a Special Issue on "Laser Micro- and Nano Processing" and invite original contributions. We seek not only to report recent developments, but also to mold the future of the field. Example topics include matter interactions, direct write processes, ultra-short pulse laser processing, surface treatment, and 3-D micro- and nano-fabrication. We look forward to receiving your contributions.

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Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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